

Combined Form PTO/SB/08A&B  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(use as many sheets as necessary)</i>				Complete if Known	
		Application Number		New application	
		Confirmation Number			
		Filing Date		December 12, 2005	
		First Named Inventor		Hiroshi ONO et al.	
		Art Unit			
		Examiner Name			
Sheet 1 of 1		Attorney Docket Number		053460	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>2</sup> (if known)		
/MM/	1	US 4,944,836		07-31-1990	Kaus D. Beyer et al.
		US			
		US			
		US			
		US			

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)			
/MM/	2	JP	2002-134442		05-10-2002	Hitachi Chem. Co., Ltd.	Abstract, cited in the ISR
/MM/	3	EPO	0 696 651 A1		02-14-1996	MEC Co., Ltd.	Yes, cited in the ISR
/MM/	4	EPO	1 260 607 A2		11-27-2002	Shipley Co., LLC	In English, cited in the ISR
/MM/	5	JP	11-172467		06-29-1999	Ebara Densan Ltd.	Abstract, cited in the ISR
	6	DE	199 26 117 A1		12-16-1999	Ebara Densan Ltd.	No, cited in the ISR
/MM/	7	JP	11-204942		07-30-1999	Hitachi Chem. Co., Ltd.	Abstract, cited in the ISR
/MM/	8	PCT	WO 00/13217		03-09-2000	Hitachi Chem. Co., Ltd.	Abstract, cited in the ISR
/MM/	9	JP	02-278822		11-15-1990	Int'l. Business Mach. (IBM)	Abstract, cited in the spec.
/MM/	10	JP	8-83780		03-26-1996	Toshiba Corp.	Abstract, cited in the spec.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>6</sup>
/MM/	11	F. B. KAUFMAN et al.; "Chemical-Mechanical Polishing for Fabricating Patterned W Metal Features as Chip Interconnects;" Journal of the Electrochem. Society, Vol. 138, No. 11, November 1991, pp.3460-3465. Cited in the specification.	

Examiner Signature	/Michael Marcheschi/ (02/04/2008)	Date Considered	
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## **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

*(use as many sheets as necessary)*

*Complete if Known*

<b>Application Number</b>	<b>10/560,228</b>
<b>Confirmation Number</b>	<b>2690</b>
<b>Filing Date</b>	<b>December 12, 2005</b>
<b>First Named Inventor</b>	<b>Hiroshi ONO</b>
<b>Art Unit</b>	<b>1755</b>
<b>Examiner Name</b>	<b>Carol M. KOSLOW</b>
<b>Attorney Docket Number</b>	<b>053460</b>

Sheet	1	of	1
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## U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>3</sup> (if known)		
/MM/	1.	US 5,897,375	A1	04-27-1999	Watts et al.
/MM/	2.	US 6,447,371	B2	09-10-2002	Brusic Kaufman et al.
/MM/	3.	US 6,217,416	B1	04-17-2001	Kaufman et al.
/MM/	4.	US 2001/0041507	A1	11-15-2001	Kaufman et al.
/MM/	5.	US 6,679,929	B2	01-20-2004	Asano et al.
/MM/	6.	US 2002/0139055	A1	10-03-2002	Asano et al.
		US			

## FOREIGN PATENT DOCUMENTS

[illegible]

## NON PATENT LITERATURE DOCUMENTS

Examiner Initials <sup>a</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>a</sup>
/MM/	10.	Chinese Office Action dated October 13, 2006, issued in corresponding Chinese Patent Application Number 038266229.	Full

<b>Examiner Signature</b>	/Michael Marcheschi/ (02/04/2008)	<b>Date Considered</b>	
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